



INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

| | |
|--------------------------------|--------------------------|
| ATTY. DOCKET NO. IO-1002-US | SERIAL NO. 09/867,286 |
| APPLICANT Ried et al. | |
| FILING DATE May 29, 2001 | GROUP 2856 |

U.S. PATENT DOCUMENTS

| *EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
|-------------------|----|-----------------|----------|----------------|-------|----------|----------------------------|
| RR | AA | 4,574,327 | 03/04/86 | Wilner | 361 | 283 | |
| RE | AB | 4,930,042 | 05/29/90 | Wiegand et al. | 361 | 280 | |
| | AC | | | | | | |
| | AD | | | | | | |
| | AE | | | | | | |
| | AF | | | | | | |
| | AG | | | | | | |

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER | PUBL. DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
|--|----|-----------------|------------|---------|-------|----------|-------------|----|
| | | | | | | | YES | NO |
| | AH | | | | | | | |
| | AI | | | | | | | |
| | AJ | | | | | | | |

OTHER DISCLOSURES (Including Author, Title, Date, Pertinent Pages of Publication, Etc.)

| | | | | | | | |
|----|----|---|--|--|--|--|--|
| HZ | AK | "Single Crystal Silicon Microstructures Using Trench Isolation", by U. Sridhar, C. H. Lau, Y. B. Miao, K. S. Tan, P. D. Foo, J. J. Liu, K. Sooriakumar, Y. H. Loh, P. John, A. T. Lay Har, A. Austin, C. C. Lai and J. Bergstrom; Transducer '99; June 7-10. 1999; pp. 258-261. | | | | | |
| | AL | | | | | | |
| | AM | | | | | | |

EXAMINER

Helmut Kewde

DATE CONSIDERED

3/9/03

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line though citation if not in conformance and not considered. Include copy of this form with next comment to applicant